	Application No.	Applicant(s)	$\overline{}$
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Notice of Allowability	09/686,653	YAMAZAKI ET AL.	
Nouce of Allowability	Examiner	Art Unit	
	Toan Ton	2871	
The MAILING DATE of this communication appears All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT R of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in or other appropriate comming IGHTS. This application is	n this application. If not included unication will be mailed in due cour	se. THIS
1. This communication is responsive to <u>papers filed 01/28/05</u>	5.		
2. The allowed claim(s) is/are <u>1,3-7,9-13,15-19,26-28,34,39.</u>	40,43,46-52 and 55-60.		
3. \boxtimes The drawings filed on <u>10 October 2000</u> are accepted by th	e Examiner.		
 4. Acknowledgment is made of a claim for foreign priority uses a) All b) Some* c) None of the: 1. Certified copies of the priority documents have 2. Certified copies of the priority documents have 3. Copies of the certified copies of the priority documents have 1 International Bureau (PCT Rule 17.2(a)). 	e been received. e been received in Applicati	on No. <u>08/751,365</u> .	from the
* Certified copies not received:			
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONN THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.	of this communication to file MENT of this application.	e a reply complying with the require	ments
5. A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which giv	nitted. Note the attached EX es reason(s) why the oath o	AMINER'S AMENDMENT or NOTIC or declaration is deficient.	CE OF
6. CORRECTED DRAWINGS (as "replacement sheets") mu	st be submitted.		
(a) ☐ including changes required by the Notice of Draftsper		w (PTO-948) attached	
1) 🗌 hereto or 2) 📗 to Paper No./Mail Date			
(b) including changes required by the attached Examiner Paper No./Mail Date	's Amendment / Comment o	or in the Office action of	
Identifying indicia such as the application number (see 37 CFR 1 each sheet. Replacement sheet(s) should be labeled as such in	I.84(c)) should be written on the header according to 37 C	the drawings in the front (not the bac FR 1.121(d).	k) of
7. DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT	osit of BIOLOGICAL MAT FOR THE DEPOSIT OF BI	ERIAL must be submitted. Note OLOGICAL MATERIAL.	the
•			T.
Attachment(s) 1. ☐ Notice of References Cited (PTO-892) 2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948) 3. ☑ Information Disclosure Statements (PTO-1449 or PTO/SB/Paper No./Mail Date 4. ☐ Examiner's Comment Regarding Requirement for Deposit of Biological Material	6. ☐ Interview S Paper No 08), 7. ☐ Examiner's	nformal Patent Application (PTO-15 Summary (PTO-413), ./Mail Date s Amendment/Comment s Statement of Reasons for Allowan 	

Application/Control Number: 09/686,653

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REASONS FOR ALLOWANCE

1. Claims 1, 3-7, 9-13, 15-19, 21-26, 28-34, 37, 39-40, 43, 46-47, 49-52 and 55-60 are allowed.

The following is an examiner's statement of reasons for allowance: the prior art of record does not anticipate nor render obvious to one ordinary skilled in the art a method of driving an IPS (in plane switching) reflective type active-matrix (TFTs) liquid crystal display device comprising a combination of various elements as claimed, more specifically, at least the followings: an interlayer insulating film provided over the thin film transistor, the interlayer insulating film being a multilayer film comprising silicon oxide and silicon nitride film.

Ohta (6108065) discloses an IPS LCD device comprising pixel and common electrodes formed on the same substrate, interlayer insulating film. However, Ohta fails to disclose 'a method of driving an IPS (in plane switching) reflective type active-matrix (TFTs) liquid crystal display device comprising a combination of various elements as claimed, more specifically, at least the followings: an interlayer insulating film provided over the thin film transistor, the interlayer insulating film being a multilayer film comprising silicon oxide and silicon nitride film'.

Applicant has also filed a terminal disclaimer to overcome the obviousness double patenting rejection.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

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CONTACT INFORMATION

2. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Toan Ton whose telephone number is (571) 272-2303.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

March 3, 2005

FOANTON DE LAMINER